

PATENT  
0717-0429P

IN THE U.S. PATENT AND TRADEMARK OFFICE.

Applicant: H. KAWANISHI et al. Conf.: 9854  
Appl. No.: 09/466,174 Group: 2828  
Filed: December 17, 1999 Examiner: J. MENEELY  
For: SEMICONDUCTOR LASER DEVICE WITH SPOT-  
SIZE CONVERTER AND METHOD FOR  
FABRICATING THE SAME

TECHNOLOGY CENTER 2800  
JUN 27 2002  
RECEIVED  
6/29/02

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dmam  
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**LETTER TO THE OFFICIAL DRAFTSPERSON**

Assistant Commissioner for Patents  
Washington, DC 20231

May 8, 2002

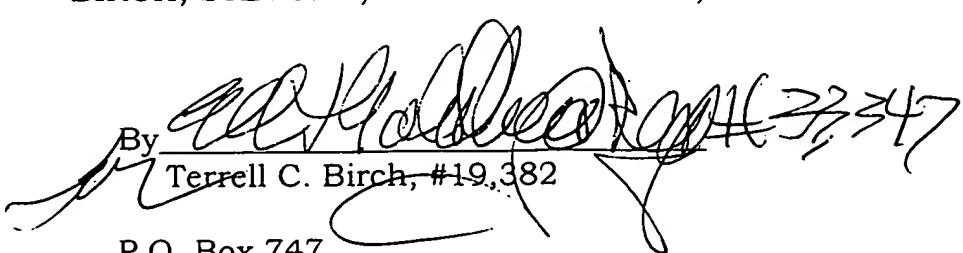
Sir:

Pursuant to the request by the Examiner in the Office Action dated February 21, 2002, the attached 2 corrected formal drawings should be made part of the record in the above-identified application.

If necessary, the Commissioner is hereby authorized in this, concurrent, and future replies, to charge payment or credit any overpayment to Deposit Account No. 02-2448 for any additional fees required under 37 C.F.R. §§1.16 or 1.17; particularly, extension of time fees.

Respectfully submitted,

BIRCH, STEWART, KOLASCH & BIRCH, LLP

By   
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TCB/EAG/kss  
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Attachments

(Rev. 11/09/01)